

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Satoshi Hayashi et al.

Serial No.: 10/581,578

Filed: December 26, 2006

For: ANION ADSORBING CARBON MATERIAL,
AS WELL AS MANUFACTURING METHOD
AND MANUFACTURING FACILITIES FOR
SAME

Group Art Unit: 1793

Confirmation No.: 4920

May 28, 2009

Costa Mesa, California 92626

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In an attempt to fully comply with the duty of disclosure set forth in 37 C.F.R. § 1.56 and in conformance with 37 C.F.R. §§ 1.97 and 1.98, applicant wishes to bring to the attention of the U.S. Patent Office the following references which were found during the prosecution of a co-pending Canadian patent application:

US Patent No. 3,835,064
US Patent Application Publication No. 2002/0010093

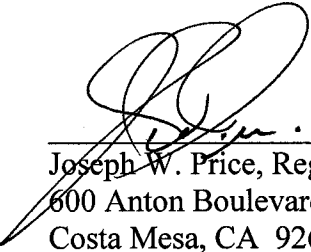
Form PTO-A820 is attached.

The undersigned attorney hereby certifies that each item of information contained in the information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing the information disclosure statement.

If the Examiner believes that a telephone conference would help further the prosecution of this case, he is respectfully requested to contact the undersigned attorney at the listed telephone number.

Very truly yours,

SNELL & WILMER L.L.P.



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